

The effect of heat treatment on the morphology and mobility of Au nanoparticles

Oras, Sven; Vlassov, Sergei; Vigonski, Simon; Polyakov, Boris; Antsov, Mikk; Zadin, Vahur; Lõhmus, Rünno; Mougin, Karine
Beilstein Journal of Nanotechnology 2020 / p. 61-67 <https://doi.org/10.3762/bjnano.11.6> [Journal metrics at Scopus](#) [Article at Scopus](#)
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Low-cost plasmonic solar cells prepared by chemical spray pyrolysis

Kärber, Erki; Katerski, Atanas; Oja Acik, Ilona; Mikli, Valdek; Mere, Arvo; Sildos, Ilmo; **Krunks, Malle** The Beilstein journal of nanotechnology 2014 / p. 2398-2402 : ill <https://doi.org/10.3762/bjnano.5.249> [Journal metrics at Scopus](#) [Article at Scopus](#) [Journal metrics at WOS](#) [Article at WOS](#)

Modification of light absorption in thin CuInS₂ films by sprayed Au nanoparticles

Katerski, Atanas; Kärber, Erki; Oja Acik, Ilona; Dolgov, Leonid; Mere, Arvo; Sildos, Ilmo; Mikli, Valdek; **Krunks, Malle** Nanoscale research letters 2014 / p. 1-6 : ill <https://doi.org/10.1186/1556-276X-9-494> [Journal metrics at Scopus](#) [Article at Scopus](#) [Journal metrics at WOS](#) [Article at WOS](#)

Plasmon resonance effect caused by gold nanoparticles formed on titanium oxide films

Tamm, Aile; Oja Acik, Ilona; **Krunks, Malle**; Mere, Arvo Thin solid films 2016 / p. 449-455 : ill <https://doi.org/10.1016/j.tsf.2016.08.059>
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Plasmonic effect of spray-deposited Au nanoparticles on the performance of CSS CdS/CdTe solar cells

Spalatu, Nicolae; Hiie, Jaan; Maticiuc, Natalia; **Krunks, Malle**; Katerski, Atanas; Mikli, Valdek; Sildos, Ilmo Applied surface science 2015 / p. 69-73 : ill <https://doi.org/10.1016/j.apsusc.2015.04.065> [Journal metrics at Scopus](#) [Article at Scopus](#) [Journal metrics at WOS](#) [Article at WOS](#)

Plasmonic modification of CdTe thin films by gold nanoparticles : methods, difficulties and solutions

Maticiuc, Natalia; **Spalatu, Nicolae**; Katerski, Atanas; Hiie, Jaan; Mikli, Valdek; **Krunks, Malle**; Dolgov, Leonid; Sildos, Ilmo Microelectronic engineering 2014 / p. 173-178 : ill <https://doi.org/10.1016/j.mee.2014.07.016> [Journal metrics at Scopus](#) [Article at Scopus](#)
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